



2823

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Docket No.: 0057-2534-2YY DIV

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

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RE: Application Serial No.: 09/429,283
Applicants: Shuichi UENO, et al.
Filing Date: October 28, 1999
For: SEMICONDUCTOR DEVICE AND METHOD OF
MANUFACTURING THE SAME
Group Art Unit: 2823
Examiner: Fourson, III, G.

SIR:

Attached hereto for filing are the following papers:

REQUEST FOR RECONSIDERATION

Our check in the amount of \$0.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

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DOCKET NO: 0057-2534-2YY DIV

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

Shuichi UENO, ET AL

: EXAMINER: FOURSON, III, G.

SERIAL NO: 09/429,283

FILED: OCTOBER 28, 1999

: GROUP ART UNIT: 2823

FOR: SEMICONDUCTOR DEVICE AND
METHOD OF MANUFACTURING
THE SAME

REQUEST FOR RECONSIDERATION

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

The following Remarks are filed in response to the non-final Office Action dated June 14, 2001.

REMARKS

Favorable reconsideration of this application is respectfully requested.

Claims 14-27 are pending in the application, all of which are rejected under 35 U.S.C. §103(a).

The Applicants wish to thank the Examiner for the interview on July 18, 2001 with Daniel Sherr and Eckhard Kuesters.

Claims 14 and 15 are rejected under 35 U.S.C. §103(a) as being unpatentable over the combination of Japanese Patent Publication No. 04157766, Gardner et al. (U.S. Patent No. 6,004,849), Choi (U.S. Patent No. 5,780,330), Chou et al. (1997 IEEE), and Kuroi et al. (J. Appl. Phys. 1995). Claims 14 and 15 recite a method comprising a step of

#14 response
8/31/01
V. Varnall
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